

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Yuichiro Sasaki, et al.  
Application No. : 10/599,205  
Filed : September 22, 2006  
Title : METHOD OF IMPURITY INTRODUCTION, IMPURITY  
INTRODUCTION APPARATUS AND SEMICONDUCTOR DEVICE  
PRODUCED WITH USE OF THE METHOD

Conf. No. : 5783  
Art Unit : 2893  
Examiner : Monica D. Harrison

Customer No. : 52054  
Docket No. : NGB-41341

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT "C"**

Sir:

This amendment is filed in response to the Office action dated July 24, 2008. The three-month period for responding to the Office action expires on October 24, 2008.

Please amend the above-identified application in the following manner.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.